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Rare Earth-Doped Integrated Glass Components: 
Modeling and Optimization

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Abstract—For the integrated optic erbium-doped phosphate silica amplifier, a comprehensive model is presented which includes high-concentration dissipative ion-ion interactions. Based on actual waveguide parameters, the model is seen to reproduce measured gains closely. A rigorous design optimization is performed, and the influence of variations in the launched pump power, the core cross section, the waveguide length, the erbium concentration, and the background losses are evaluated. Optimal design proposals are given, and the process reproducibility of the proposed optimal design is examined. Requirements for process parameter control in the wafer fabrication are set up.

I. INTRODUCTION

FEW components have revolutionized the area of optical research as the rare earth-doped optical amplifier and laser. This is mainly due to the eye safe transition around 1.55 µm of erbium and the 1.3 µm emission of neodymium or praseodymium which, respectively, coincide with the low-loss window and the zero dispersion wavelength of standard optical fibers. Although fiber-versions of these components are already commercially available, the integrated optic version seems to be competitive and in some ways unsurpassed by fibers. This is because integrated optics offer prospects of active components to be integrated on the same substrate as filters, couplers, taps, and multiplexers so optical switching and multiplexing can be made locally on the wafer. The integration offers robust devices, compact size, multiple device fabrication on the same substrate, and packaging at lower cost.

From the variety of rare earth ions and integrated optic substrate materials, the main part of this paper will focus on the erbium-doped glass components, although differences from other rare earth ions are discussed when significant. Glass is chosen as host, as it is stable to changes of environment, has a low propagation loss, and the potential of low-loss coupling to standard optical fibers. The 1.55 µm narrow linewidth erbium source is of utmost importance for high-bit-rate long-distance fiber optic communication and for coherent optical transmission, but also for spectroscopic, telemetry [1], and special metrological applications [2]. Combined with the advantages of integration and dense packing, a miniaturized diode-pumped eye safe source will be extremely attractive for the medical industry and applications as sensors, laser radars, free-space communication, tactical training range finding, security systems [3], and as superradiant sources for optical gyroscopes [4]. In addition, other wavelengths could be reached by using the transitions ranging from the IR part of the spectrum to the visible part, which are accessible through upconversion pumping schemes. In particular, compact visible laser sources are needed for optical disk storage purposes [5], medical, and sensor applications.

Accurate numerical modeling of rare earth-doped integrated optic components are of extreme importance in the development and processing of high-performance devices, and are required far more than for fiber optimization. Compared to active fibers, we have, after the fabrication, one adjustment parameter less to compensate for minor deviations during processing, as the doped waveguide length is determined during the fabrication. This leaves the pump power as the only adjustable design parameter, and sets up requirements for accurate predicted design proposals before processing. In this paper, we present an overview of different rare earth incorporation techniques of active wafers, with their limitations to certain glass compositions, as the host glass development can be viewed as part of the integrated optical amplifier optimization. An overview of applications and the state of the art is given. For illustration and simplification, we then concentrate on the erbium-doped phosphor/silica-core silica-on-silicon wafer amplifier, present a numerical model for this component, verify the model with measurements, and perform a rigorous design optimization of the high-gain component.

II. HOW TO INCORPORATE RARE-EARTH IONS IN GLASS

Diffusion and deposition are two basic different methods used for core layer introduction in integrated optics (IO). Channel waveguides are formed in the former by diffusing index raising materials through a slide in a substrate surface covering mask, while for deposition, photolithography can be used to write structures on the surface, whereafter reactive ion-etching (RIE) is used to remove any core areas not masked. Buried waveguides are made in the diffusion process by extraction of core material near the surface [6], while in the deposition, an extra cladding layer is deposited on top of the ridged waveguide. Also, the techniques by which rare earth (RE) ions are impregnated to the core most often differ from these processes. Generally, rare earth ions are introduced into the core glass of deposited waveguides, while the core is introduced into the rare earth glass for diffused components. Fig. 1 shows different combinations of core layer fabrication
techniques and rare earth incorporation processes that have been published within the last few years.

One should bear in mind that phosphate glasses (or, alternatively, alumino-silicate glasses) seem to be the best suited host materials for most applications of rare earth-doped IO amplifiers. This is because phosphate (and aluminum) act as network modifiers in the glass, thereby eliminating the clustering tendency as reported for highly RE-doped fibers [7]. Phosphate increases the refractive index, and is therefore often used as a core material in deposited waveguides. In addition, it has a lack, compared to Ge-silica, of the unwanted excited state absorption, ESA, around the 1.35 μm Nd transition [8]. However, as phosphate glasses have large effective phonon frequencies (high nonradiative transition rates), slightly reduced quantum efficiencies can be expected for some compositions [9].

III. MODELING

The modeling of rare earth-doped channel waveguides differs on several points from the modeling of rare earth-doped fibers. One difference is the noncircular symmetric core cross section, which typically are rectangular for deposited and elliptical for diffused waveguides. Another is the noncircular symmetric rare earth doping profile; this can be a rectangular step-like profile for while deposition or solution doping, vertically Gaussian shaped for doping by ion implantation, or located outside the core as network modifiers in the glass, thereby eliminating the population inversion. A similar equation to this process is made by including a term proportional to $k_{2n+1}^2$ in the rate equations. $n_2$ is the population in the upper laser level, and $k_2$ is the upconversion constant of about $1 \times 10^{-23}$ m$^3$/s [32]. Another model also includes higher order upconversion processes [29], while others have found that the upconversion constant is concentration-dependent [31], yielding a cubic equation for the determination of the population inversion. A similar equation appears when the performance degradation is modeled through the observed relation between fluorescence lifetime and the concentration [28], as will be described in detail below. The neodymium system acts different. Due to intermediate states between the upper and lower laser level, the inefficiency is caused by cross relaxations to these, involving one excited ion and one in the ground state, followed by a quick relaxation to the ground state (illustrated on the right hand side of Fig. 2). A term proportional to $k_{ij} n_i n_j$ should be applied for the simple approximation in this case, $k_{ij}$ being the cross-relaxation coefficient between levels $i$ and $j$.

For illustration, we have concentration our modeling on erbium-doped phosphate–silica waveguide cores confined in silica cladding, with erbium homogeneously distributed within the core. See Fig. 3. The model is developed from an experimentally verified and accurate Er-doped fiber amplifier model [7] with changes made to fulfill the above-mentioned differences in structure. The circularly symmetric LP$_{01}$ mode...
description has been replaced with the fundamental $E_{11}^P$ or $E_{11}^R$ modes, calculated by an accurate optimized effective index method [33]. This method is a variational method, where the trial function is the product of two slab waveguide solutions, $X(x, n_x)$ and $Y(y, n_y)$, one for the $x$ dependency and one for the $y$ dependency. The slab waveguides have core width $A$, height $B$, and core refractive indexes $n_x$ and $n_y$, respectively. $n_x$ and $n_y$ are chosen so the integral

$$
\int_{-\infty}^{\infty} \int_{-\infty}^{\infty} X Y \left[ \frac{\partial^2}{\partial x^2} + \frac{\partial^2}{\partial y^2} + n^2(x, y)k^2 \right] X Y dx dy
$$

is maximum. A term accounting for the passive waveguide loss is included in the propagation equations, and the dissipative ion-ion interactions are included through their influence upon the fluorescence lifetime. Since little information about quenching is available for highly concentrated Er-doped glasses, the empirical formula that relates the fluorescence lifetime $\tau_f$ to the ion concentration for Nd-doped glasses [9] is adapted, taking into account that only processes between excited ions occur for the Er system:

$$
\tau_f = \frac{\tau_0}{1 + (x(x, y, z) \cdot \rho/Q)^2}.
$$

Here, $x(x, y, z)$ is the local population inversion, $\rho$ the Er concentration, $\tau_0$ the fluorescence lifetime in the limit where the concentration approaches zero, and $Q$ the quenching concentration where $\tau_f = (\frac{1}{2})\tau_0$. The fluorescence lifetime combines all transitions from the metastable state through the relation $\tau_f = (\tau_{ra}^{-1} + \tau_{nr}^{-1})^{-1}$, where $\tau_r$ is the radiative and $\tau_{nr}$, the nonradiative transitions. By inserting (1) in the rate equations, a cubic equation of the population inversion arises:

$$
x(x, y, z)^3 + \left[ (R_{PA}(x, y, z) + W_{SA}(x, y, z)) + R_{PE}(x, y, z) + W_{SE}(x, y, z) \right] \tau_0 + 1 \right]
\cdot \left( \frac{Q}{\rho} \right)^2 x(x, y, z)
\right)
\left( \frac{Q}{\rho} \right)^2 \tau_0 = 0.
$$

$R_{PA}$ and $R_{PE}$ are the pump absorption and emission rates, respectively, and $W_{SA}$ and $W_{SE}$ are the signal absorption and emission rates [7]. The model takes into account the forward- and backward-amplified spontaneous emission, ASE, each presented in 150 frequency slots from 1.4 to 1.7 $\mu$m. The ASE, signal, and pump propagation yield 302 coupled differential equations that are solved by numerical integration through the waveguide. The emission cross section, shown in Fig. 4, was determined from a photoluminescence spectrum, measured on Er-doped P-glass [10] (8 wt% $P_2O_5$). The spectral shape is invariant to variations of the Er concentration. Absolute values of the emission cross section were calculated from the experimentally determined emission cross section using an approximate treatment of the McCumber theory [34]. This theory has shown the ability to provide accurate spectral values of cross sections for the $4I_{15/2} \leftrightarrow 4I_{13/2}$ transition of Er-doped glasses and yields $\sigma_e(n) = 5.6$ kb at the peak. The absorption cross section at 0.98 $\mu$m, $\sigma_a(n) = 1.3$ kb was determined from a 0.7 dB/cm pure optical absorption measurement [35] in an Er-doped P-glass channel waveguide.

IV. MODEL VERIFICATION

Verification of the model was made by comparing calculations and measurements on a well-examined waveguide amplifier [35], having a buried waveguide core of $A_m \times B_m = 8 \times 7 \mu$m$^2$, a length of $L_m = 19.4$ cm, and a refractive index difference of 1.2% (8 wt% $P_2O_5$). A 0.980 $\mu$m pump was used, together with the 1.535 $\mu$m signal in a copropagating configuration. The concentration-dependent background losses increased linearly from $\alpha_B = 0.14$ to 0.28 dB/cm for the pump, and from $\alpha_s = 0.11$ to 0.22 dB/cm for the signal for concentrations below $\rho = 115 \times 10^{-24}$ m$^{-3}$. The pump power dependence upon the net gain was examined for a fixed mean Er concentration of $n_{er} = 48 \times 10^{24}$ m$^{-3}$. Calculations for different quenching concentrations above $Q = 17 \times 10^{24}$ m$^{-3}$ are shown in Fig. 5 in comparison with the measurements (circles). $Q \rightarrow \infty$ corresponds to negligible effects of the ion-ion interactions, and yields a conflict of up to 10 dB with the measurements. Decreasing $Q$ diminishes this inconsistency, and $Q = 17 \times 10^{24}$ m$^{-3}$ yields a difference
of less than 1 dB in the entire pump power interval. The $\tau_0 = 13.7 \text{ ms}$ lifetime reported in [10] was used in the calculations, but as different fabrication processes might yield different magnitudes of $\tau_0$, the correlation among gain, pump power, $\tau_0$, and Q has been examined. Gain curves deviate only a few tenths of a decibel from the case with $\tau_0 = 13.7 \text{ ms}$ if the Q factor at the same time is increased ($Q = 25 \cdot 10^4 \text{ m}^{-3}$ for $\tau_0 = 8 \text{ ms}$). In addition, significant Er ion–ion interactions have been observed at levels of $\sim 10^4 \text{ m}^{-3}$ for both pure silica and Ge-doped silica fibers [9], and a rapid fluorescence lifetime decrease reported at concentrations above 0.1 wt% ($8 \cdot 10^4 \text{ m}^{-3}$) in the amplifier experiment [35].

The gain versus concentration dependence is examined in Fig. 6 for a fixed pump power of 100 mW. Significant gain reductions are observed for concentrations above $10^4 \text{ m}^{-3}$ (approximately ten times higher than the typical concentrations in Er-doped fibers). However, the pronounced gain differences to the case of no ion–ion interactions grow at higher concentrations to 50 dB at $\rho = 1.15 \cdot 10^4 \text{ m}^{-3}$. By reducing the quenching concentration to $Q = 1.7 \cdot 10^4 \text{ m}^{-3}$, the theoretical curve shows excellent agreement with the measured values for concentrations up to $60 \cdot 10^4 \text{ m}^{-3}$. Experimental data display a stronger deflection than the calculated in the remaining interval, perhaps due to even higher order nonlinear ion–ion interactions.

V. RARE EARTH-DOPED COMPONENTS

The present research within rare earth-doped integrated components can basically be grouped into three different categories: lasers, lossless Y branches, and high-gain amplifiers, each group with optimal design parameters that deviate remarkably from the others. However, combinations of these, i.e., an amplifying Y branch or a Y branch laser with application for dual-output, mode-selected or Q-switched operation, may also find attraction.

Lasers are the most simple of these to realize, as they require relatively low rare earth concentrations. As in the case of active fiber development, the focus was first put on the transitions in Nd$^{3+}$ because neodymium acts as a four-level laser system, and it is therefore easier to handle (achieve population inversion) than the three-level erbium system, plagued by ground state absorption. Although Nd-doped glass waveguides were reported 20 years ago [36], the recent development was started by the presentation of an Ag$^+K^+$ ion-exchanged waveguide in highly Nd-doped silicate glass by Babukova et al. in 1985 [37]. But six years later in 1991, Mwarania et al. [38] presented the first truly single-mode glass channel waveguide laser. A 7.5 mW threshold and a 6% slope efficiency were measured on a 17 mm long Na$^+K^+$ ion-exchanged device. A detailed review of this six-year development is given in [5]. A pump threshold as low as 0.6 mW followed by a slope efficiency of 24% in a 5 mm long Ag$^+K^+$ ion-exchanged waveguide [39] is, to the best of our knowledge, the most pronounced low-power Nd laser results obtained so far. The development of low-power Nd lasers is illustrated in Fig. 7. As can be seen, the most significant results are obtained with phosphate glasses (solid lines). Apart from the dominant 1.06 $\mu$m transition [14] lasing, although less significant, others also have been reported around 0.91 $\mu$m [40], 1.33 $\mu$m, and 1.36 $\mu$m [8] for the Nd system.

Reports on erbium-doped glass lasers were seen in 1991 with the presentation of an FHD-processed silica-on-silicon laser by Kitagawa et al. [12]. Co-doping with ytterbium is generally used with the Er system so as to enhance the absorption efficiency by utilizing the Yb$^{2+}F_{5/2} \rightarrow$ Er$^{3+}J_{11/2}$ energy transfer process [7]. To our knowledge, the best low-power Er-laser results obtained so far are a 16 mW threshold and a 10% slope efficiency from a 2.5 mm thick and 4 mm diameter Er/Yb–phosphate disk [30].

Lossless Y branches can be viewed as a first step towards complex multichannel devices, as the $1 \times 2$ geometry can be extended to a large number of output ports. The lossless Y branch requires an amplification high enough to compensate for the 3 dB splitting loss, the background loss, and possibly coupling loss; in all, about 5–7 dB of amplification is needed. 85 mW of 807 nm pump was used to overcome the splitting.

Fig. 5. Gain versus pump power, calculated for different Q values (should be multiplied by $10^4 \text{ m}^{-3}$). Measurements (read from [12]) are shown as circles.

Fig. 6. Gain versus erbium concentration for different Q values (should be multiplied by $10^4 \text{ m}^{-3}$). Measurements (read from [12]) are shown as circles.

Fig. 7. Laser output power versus pump power for different integrated Nd lasers presented in the literature. Solid line: phosphate silica glass host. Dotted line: silicate glass host.
loss in a 24 mm long Nd-doped device [41], defined by ion exchange in a silicate glass, while 60 mW of 980 nm pump was found sufficient to compensate for splitting and excess loss in a 23 cm Er-doped silica-on-silicon device [31]. In addition to the fabrication of single-output port amplifiers, the branch proportional $L_1/(L_1 + L_2)$ is an extra design parameter that must be optimized to reduce the pump power required. $L_1$ and $L_2$ are the length of doped waveguide, respectively before and after the ramification, as illustrated in Fig. 8. Kitagawa [31] has reported the optimum position to be 0.9 for an Er-doped silica-on-silicon component.

Two significant deviating parameters for the high-gain amplifier are the rare earth concentration and the waveguide length, both considerably larger than for the laser and Y branch components. The promising silica-on-silicon components especially require very long lengths, but 170 cm long passive channel waveguides in a coiled configuration (bending radius of 5 mm) have been realized [42] with low propagation loss (0.038 dB/cm). Optimal design of this type of amplifier will be examined in detail below; here, it should be mentioned that the highest net gain reported for integrated glass amplifiers is 23 dB [31] from a 36 cm long erbium-doped P silica-on-silicon component, pumped with 240 mW of 0.98 μm light. Also, 10 dB net gain from an only 4.7 mm long Er/Yb-doped composite glass waveguide amplifier (∼21 dB/cm) has been reported, applying only 30 mW of pump power [21].

VI. HIGH-GAIN AMPLIFIER OPTIMIZATION

We will now select the high-gain component for optimization, and take as reference the above-reported amplifier [35] $(A_m, B_m, L_m, \rho_m) = (8 \mu m, 7 \mu m, 19.4 cm, 48 \times 10^{-4} m^{-3})$ applying 100 mW of pump power. Five different design parameters are evaluated, that is, waveguide length, core cross section, erbium concentration, pump power, and background loss. The reference gain, measured (symbols) and calculated (lower solid line), are shown again versus erbium concentration in Fig. 9, all determined from the fixed length of 19.4 cm. An optimum length exists, however, for each single concentration, whereas the gain reaches its maximum. Shorter lengths yield an incomplete utilization of the pump, whereas the pump for longer lengths cannot invert the Er ions sufficiently. The length-optimized gain and the optimum length for the reference component are shown as dashed lines in Figs. 9 and 10, respectively.

It is seen that the reference length (horizontal line) is less than half the optimum, and that the highest reference gain can be increased with 3 dB simply by changing the concentration to $\rho = 30 \times 10^{24} m^{-3}$ and the length to 45 cm. The evolution in the optimum waveguide length is seen to increase from a few cm at very high concentrations to 60 cm at $\rho = 13 \times 10^{24} m^{-3}$.

For smaller concentrations, the optimum length approaches zero because the total background loss becomes comparable with the gain accumulation. The length- and concentration-optimized amplifier gain may be further increased if the waveguide core cross section is also optimized. By decreasing the reference core, the overlap integral between the Er-doped region and the mode profile is increased, followed by gain improvements. However, for very small cross sections, yielding long optimum lengths the accumulated background loss will diminish the gain seriously, so obviously an optimum exists. The upper solid curves in Figs. 9 and 10 represents calculations where the core cross section and the waveguide length have been optimized to maximum gain simultaneously for each concentration considered. A quadratic core cross section is considered to achieve a fundamental mode that matches the circularly symmetric fundamental mode of optical fibers. The core size optimization yields an additional 3 dB gain at the optimum concentration $\rho = 41 \times 10^{24} m^{-3}$, a core width of 4.6 μm, and a length of 53 cm. The optimum core size varies inversely proportional to the concentration from 6.2 ($\rho = 10 \times 10^{24} m^{-3}$) to 3.4 μm ($\rho = 115 \times 10^{24} m^{-3}$). Also, the evolution of the noise figure is shown for the latter optimization, yielding a minimum of 5.1 dB. An even lower noise figure can be obtained with increasing gain by increasing the pump power, or for a fixed pump power (and decreasing gain), by reducing the waveguide length.

The above-determined design combination of $A$, $\rho$, and $L$ is optimum for a fixed pump power of 100 mW. By changing the power, the design must be changed, which is why a three-dimensional simultaneous optimization of these parameters is made for the pump power evolution. This is illustrated in Fig.
Fig. 11. Gain versus pump power. Circles: measurements read from [35]. Lower solid line: reference calculation. Upper solid line: simultaneous length, core, and concentration optimization. Dotted line: corresponding noise figure.

Fig. 12. Gain contour curves for different waveguide lengths and erbium concentrations, corresponding to the reference setup.

Fig. 13. 5-dB (dotted lines) and 13-dB (solid lines) gain contour curves for different waveguide lengths and erbium concentrations. Smallest curves with background losses as for the reference. Middle curves with $\alpha_p = \alpha_s = 0.11$ dB/cm. Largest curves with $\alpha_p = \alpha_s = 0.08$ dB/cm.

Fig. 14. Optimal gain and erbium concentration versus background loss for different pump power levels. $A = 4.65 \mu$m.

11 in comparison with the reference results. The resulting gain curve (upper solid line) clearly illustrates how a high-gain component can be obtained by proper design. $(p_{\text{opt}}, A_{\text{opt}}, L_{\text{opt}})$ increase with pump power from $(31 \cdot 10^{23} \text{ m}^{-3}, 4.1 \mu\text{m}, 29 \text{ cm})$ at 20 mW of pump to $(61 \cdot 10^{24} \text{ m}^{-3}, 5.4 \mu\text{m}, 61 \text{ cm})$ at 640 mW. Gains above 35 dB are obtained in the latter situation, and the corresponding noise figure approaches 4 dB.

The latter of the five design parameters to be examined is the background loss. To evaluate its influence upon the optimal amplifier design, we consider the gain contour curves for the reference amplifier, as shown in Fig. 12. This shows combinations of waveguides length and erbium concentration required to obtain a certain gain. Note that the shortest allowable length for a 13 dB amplifier with reference design is 38 cm, while the shortest allowable concentration is $32 \cdot 10^{24} \text{ m}^{-3}$. Consider, now, background losses that are concentration independent, $\alpha_p = \alpha_s = 0.11$ dB/cm and $\alpha_{\text{opt}} = \alpha_s = 0.08$ dB/cm. This change has an enormous effect upon the design, and the expansion of the 5 dB (dotted) and 13 dB (solid lines) gain contour curves are shown in Fig. 13. The shortest lengths required for a 13 dB amplifier are halved to 22 cm $(\alpha = 0.11$ dB/cm) and 18 cm $(\alpha = 0.08$ dB/cm). Minimum required concentrations are reduced to $21 \cdot 10^{24} \text{ m}^{-3} (\alpha = 0.11$ dB/cm) and $14 \cdot 10^{24} \text{ m}^{-3}$, respectively, while at the same time, the highest possible gain, is increased to 31.8 dB, all for a fixed pump power of 100 mW.

The relationship among background loss, pump power, optimal gain, and erbium concentrations is clarified in Fig. 14 for a fixed waveguide width of 4.65 $\mu$m. In the situation with extremely small background loss, gains in excess of 40 dB can be reached with 60 mW of pump. The design is very critical to variations of $\alpha$, i.e., the slope around a state-of-the-art, realistic processed reproducible background loss of 0.08 dB/cm is up to 300 dB/(dB/cm). An almost linear relationship between background loss and erbium concentration is observed for $\alpha > 0.05$ dB/cm. The slope of around $105 \text{ m}^{-3}/(\text{dB/cm})$ for pump levels considered is slightly increasing versus pump power from $100 \text{ m}^{-3}/$(dB/cm) ($P_p = 30$ mW) to $130 \text{ m}^{-3}/$(dB/cm) ($P_p = 500$ mW). A somewhat more complicated evolution is seen from Fig. 15 to exist for the optimal waveguide length. High background losses (> 0.07 dB/cm) yield increasing lengths versus pump power up to 100 mW. However, for lower loss values, a maximum length is observed. This maximum length arises from the correlation and weighting between, on the one hand, the gain degradation caused by concentration increase and, on the other hand, gain degradation caused by length increase. It is remarkable that the optimum length is unchanged over a 50 mW pump power interval for $\alpha = 0.07$ dB/cm.

VII. PROCESS REPRODUCIBILITY

Reproducibility of the design parameters during the different processing steps will determine how accurately the above-shown design curves can be followed. These process parameters are core width, length, and height, the refractive index difference, background loss, and erbium concentration. It is expected that a specified concentration can be met within $\pm 5\%$ in the more controllable processes, although it might be much more uncertain for others. The refractive index and layer thickness are parameters related to the deposition process, and are strongly dependent upon deposition method and speed. A standard process yields typical variations over one 4 in
Fig. 15. Optimal waveguide length versus pump power for different background loss values. $A = 4.65 \, \mu m$.

Fig. 16. Gain for different process parameter deviations from the optimum design. Five $z$-axis units correspond to a 5% thickness increase, 0.07% $\Delta n$ increase, 5% increase in $x$, and 0.015 dB/cm decrease in background loss.

A comprehensive model of an integrated, highly erbium-doped phosphate glass amplifier has been found to reproduce measured gains up to concentrations of $60 \cdot 10^{24} \, m^{-3}$. The emission and absorption cross section peaks at 1.55 $\mu m$ of Er-doped phosphate silica are found to be $5.6 \cdot 10^{-25} \, m^2$. Ion-ion interactions are found to reduce the amplifier gain in excess of 50 dB for very high doping levels, and optimal erbium concentrations have been determined as approximately $30 \times 60 \cdot 10^{24} \, m^{-3}$ for realistic background losses and pump power levels below 100 mW. The optimal concentrations are found to increase linearly with a background loss of around $105 m^{-3}/(db/cm)$, having a slightly increasing slope for increasing pump power levels. The optimal active waveguide length is found to be up to 175 cm for background losses of 0.03 dB/cm, and strongly decreases for increasing loss. Net gains in excess of 40 dB are predicted for only 60 mW of pump power in the situation with small background loss. Performance degradation due to reported variations in process parameters during a multiple wafer fabrication are found to be very significant. The background loss is the most critical parameter to control; a deviation of 0.015 dB/cm from the assumed value in the design results in a 4.2 dB gain decrease. Variations below 0.5 dB require control of core thickness better than $\pm 5\%$, $\Delta n$ better than $\pm 0.02\%$, and background losses better than $\pm 0.001 \, dB/cm$. The latter requirement diminishes significantly with the wanted amplifier gain, and thereby required length.

IX. ACKNOWLEDGMENT

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